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			Complete If Known	
			Application Number	10/541,145
			Filing Date	June 29, 2005
			First Named Inventor	Tobias Schmidt
			Art Unit	1743
			Examiner Name	Jan M. Ludlow
			Attorney Docket Number	P&P-101

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article, (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T ²
	R1	FEUSTEL, A. et al., "A Micro Mass Spectrometer," <i>Sensor Kongressband</i> , 1995, pages 465-470.		
	R2	FEUSTEL, A. et al., "A Microsystem Mass Spectrometer," <i>Micro Total Analysis Systems</i> , 1994, pages 299-304.		
	R3	GREVESMÜHL, B. "Miniaturisierte Gaschromatographie-Module verbessern Prozesse in der Chemie," <i>P&A Kompendium</i> , 2005/2006, pages 164-165		
	R4	LEHMANN, U., "Analysis in miniature," <i>Vacuum Solutions</i> , November/December 1998, pages 13-15.		
	R5	LEHMANN, U., "Autarky Gas Chromatographic System Realized in MEMS Technology on a Credit Card-Sized Board," <i>Abstracts Pitcon</i> , 2005, 180-9.		
	R6	LEHMANN, U., "Kleinste Flüsse messen," <i>Journal Forschung und Entwicklung</i> , Heft 6, 2002, Vol. 44, pages 32-35.		
	R7	LEHMANN, U. et al., "A micro gas chromatograph based on a plasma polymerized siliconorganic stationary phase," <i>Sensor Kongressband II</i> , 1997, pages 151-153.		
	R8	LEHMANN, U. et al., "Micro machined analytical gas chromatograph with a plasma polymerised stationary phase," <i>Sensor Proceedings II</i> , 2001, pages 487-492.		
	R9	LEHMANN, U. et al., "Micro machined gas chromatograph based on a plasma polymerised stationary phase," <i>Micro Total Analysis Systems</i> , 2000, pages 167-170.		
	R10	LEHMANN, U. et al., "Mikrogaschromatograph basierend auf einer plasmapolymersierten siliziumorganischen stationären Phase," <i>Jahrg. 1999, Vol. 53, No. 7</i> , pages 47-49		

Examiner Signature	/Shogo Sasaki/	Date Considered	02/09/2009
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Sheet 2 of 2

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/S.S./	R11	LEHMANN, U. et al., "A Miniaturised Gas Chromatographic Module on a Credit Card Sized Motherboard," <i>Sensor Proceedings</i> , 2003, pages 157-161.	
	R12	LEHMANN, U. et al., "A miniaturized gas chromatograph for autonomous and longtime measurements," <i>Sensor Proceedings I</i> , 1999, pages 155-158.	
	R13	LEHMANN, U., "A Packed Column Realized on a 1 cm ² Sized Silicon Glass Chip for Permanent Gas Separation," <i>Abstracts Pittcon</i> , 2005, 1910-5P.	
	R14	LEHMANN, U., "World's Smallest, Self-Sufficient Gas Chromatography Module from SLS Micro Technology," <i>Abstracts Pittcon</i> , 2004, 1100-100.	
	R15	"Small is Beautiful," <i>The Column</i> , July 2005, pages 22-23.	
	R16	PETZOLD, G. et al., "A Micro Mass Spectrometer," <i>Micro Total Analysis Systems</i> , 2001, pages 224-226.	
	R17	SIEBERT, P. et al., "Processing of Complex Microsystems: A Micro Mass Spectrometer," <i>Symposium on Design, Test, and Microfabrication of MEMS and MOEMS</i> , March-April 1999, Vol. 3680, pages 562-571, Paris, France.	
	R18	SIEBERT, P. et al., "Surface microstructure/miniature mass spectrometer: processing and applications," <i>Appl. Phys. A</i> , 1998, Vol. 67, pages 155-160.	
	R19		
	R20		

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